

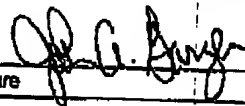
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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
**BECKER ET AL.**

Serial No.: UNKNOWN

Filed: HEREWITH

For: *Method for Enhancing Oxide to Nitride  
Selectivity Through the Use of Independent  
Heat Control*

Group Art Unit: UNKNOWN

Examiner: UNKNOWN

Atty. Dkt. No.: MCRO:284-2/11762/LWT

**INFORMATION DISCLOSURE STATEMENT**

Box: Patent Application  
Commissioner for Patents  
Washington, D.C. 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be

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an admission that the information cited is prior art or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the examiner initial the spaces on form 1449 to evidence the same.

Respectfully submitted,

*Terril G. Lewis*

Terril G. Lewis  
Reg. No. 46,065  
Attorney for Applicant

HOWREY SIMON ARNOLD & WHITE,  
LLP  
750 Bering Drive  
Houston, Texas 77057-2198  
(713) 787-1400

Date: 08/06/01

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Signature	<i>James O. Haws</i>

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
**BECKER ET AL.**

Serial No.: 09/923,058

Filed: August 6, 2001

For: **METHODS FOR ENHANCING  
SILICON DIOXIDE TO SILICON  
NITRIDE SELECTIVITY** (as earlier  
amended)

Group Art Unit: 1763

Examiner: UNKNOWN

Atty. Dkt. No.: MCRO:284-2/11762/LWT  
(11762.0284.CNUS01)SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTAssistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not meant to be construed as a representation that a search has been made, and is not

to be construed to be an admission that the information cited is prior art or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).

This Supplemental Information Disclosure Statement is being filed prior to the receipt of a first Office Action reflecting an examination on the merits, and hence is believed to be timely in accordance with 37 C.F.R. § 1.97(b). Accordingly, no fee is believed to be due. Should any fees be deemed necessary, however, the Commissioner is hereby authorized to charge any additional fees which may be required to Deposit Account No.:01-2508/MCRO284—2/LWT.

For Japanese reference numbers B2, B4-B6, and B9, a full English translation of these references is not available to the Applicant at this time. As such, because of the significant expense in obtaining a full translation, only a translation of the abstract is being filed herewith for these patents, along with copies of the figures. However, should the Examiner believe that a full translation would be necessary, Applicant will gladly provide a full translation at the Examiner's request.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the examiner initial the spaces on the accompanying Form PTO-1449 to evidence the same.

Respectfully submitted,



Terril G. Lewis  
Reg. No. 46,065  
Attorney for Applicant

HOWREY SIMON ARNOLD & WHITE,  
LLP  
750 Bering Drive  
Houston, Texas 77057-2198  
(713) 787-1400

Date:

1-31-2002

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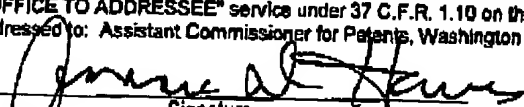
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

David S. Becker, et al.

Serial No.: 09/923,058

Filed: August 6, 2001

Group Art Unit: 1763

Examiner: Unknown

Atty. Dkt. No.: 11762.0284.CNUS01  
(MCRO:284—2)For: METHODS FOR ENHANCING SILICON  
DIOXIDE TO SILICON NITRIDE  
SELECTIVITY (*as earlier amended*)SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTAssistant Commissioner for Patents  
Washington, DC 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents as required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not meant to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is prior art or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).

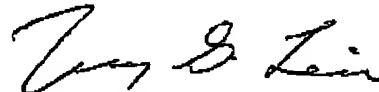
This Supplemental Information Disclosure Statement is being filed prior to the receipt of a first Office Action reflecting an examination on the merits, and hence is believed to be timely in accordance with 37 C.F.R. § 1.97(b). Accordingly, no fee is believed to be due. Should any fees be deemed necessary; however, the Commissioner is hereby authorized to charge any additional fees which may be required to Howrey Simon Arnold & White Deposit Account No.:01-2508/MCRO284—2/LWT.

Should the Examiner believe that a full translation of Japanese Patent reference numbers B1-B6 is necessary, Applicant will gladly procure a full translation at the Examiner's request.

Pursuant to MPEP § 2001.06(c), Applicant also wishes to point out that the patents issuing from parent applications to the present application (serial 09/344,277, issued as USP 6,287,978; serial 08/905,891, which issued as USP 6,015,760; and serial 07/898,505, which issued as USP 5,286,344) have been involved in a litigation, namely *Sandisk Corp. v. Micron Tech., Inc.*, Civ. No. 02-2627CW (N.D. Cal.). Pursuant to the local rules in that court, Sandisk filed "Preliminary Invalidity Contentions" for each of the three parent patents, which are attached as references C12-14 on Form 1449. After reviewing this matter with litigation counsel, it is my understanding that this case ultimately settled without further discovery pertinent to the invalidity or enforceability of the claims in those patents, and without any claim in those patents being rendered invalid or unenforceable.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the Examiner initial the spaces on the accompanying Form PTO-1449 to evidence the same.

Respectfully submitted,



Terril G. Lewis

Reg. No. 46,065

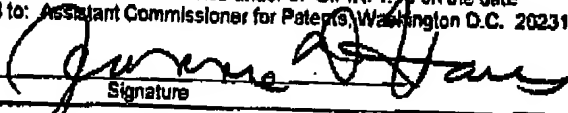
Attorney for Applicant

MICRON TECHNOLOGIES, INC.

Howrey Simon Arnold & White, LLP  
750 Bering Drive  
Houston, TX 77057-2198  
(713) 787-1449

Date: 2-12-03

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

David S. Becker, et al.

Serial No.: 09/923,058

Filed: August 6, 2001

Group Art Unit: 1763

Examiner: Unknown

Atty. Dkt. No.: 11762.0284.CNUS01  
(MCRO:284-2)For: METHODS FOR ENHANCING SILICON  
DIOXIDE TO SILICON NITRIDE  
SELECTIVITY (*as earlier amended*)SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTAssistant Commissioner for Patents  
Washington, DC 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form PTO-1449 be considered by the Examiner and made of record. A copy of the listed document as required by 37 C.F.R. § 1.98(a)(2) is enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not meant to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is prior art or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b), or that such information constitutes prior art.

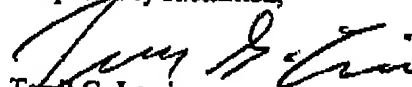


This Supplemental Information Disclosure Statement is being filed prior to the receipt of a first Office Action reflecting an examination on the merits, and hence is believed to be timely in accordance with 37 C.F.R. § 1.97(b). Accordingly, no fee is believed to be due. Should any fees be deemed necessary, however, the Commissioner is hereby authorized to charge any additional fees which may be required to Howrey Simon Arnold & White Deposit Account No. 01-2508/MCRO284—2/LWT.

In accordance with MPEP § 2001.06(c), and similar to the previously filed Supplemental Information Disclosure Statement in this matter (filed February 12, 2003), Applicant wishes to point out that attached reference C1 is the Complaint for Declaratory Relief for the litigation which the parent applications of the present invention was involved in, namely *Sandisk Corp. v. Micron Tech., Inc.*, Civ. No. 02-2627CW (N.D. Cal.). After reviewing this matter with litigation counsel, it is my understanding that this case ultimately settled without further discovery pertinent to the invalidity or enforceability of the claims in those patents, and without any claim in those patents being rendered invalid or unenforceable.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the Examiner initial the spaces on the accompanying Form PTO-1449 to evidence the same.

Respectfully submitted,



Terrell G. Lewis  
Reg. No. 46,065  
Attorney for Applicant  
MICRON TECHNOLOGIES, INC.

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Houston, TX 77057-2198  
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Date: 2-19-03